1	Supporting Information for:			
2	Antisolvent processing of lead halide perovskite thin films studied by in-situ			
3	X-ray diffraction			
4	Karsten Bruening ¹ , Christopher J. Tassone ¹			
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Figure S1 | Power conversion efficiency of record and select antisolvent-produced perovskite

- 8 devices over time. See Table S1 for references.
- **Table S1** | References for Figure S1.

Author	Journal	Reference	
Kojima	JACS	1	
Im	Nanoscale	2	
Kim	Sci. Rep.	3	
Ball	EES	4	
Burschka	Nature	5	
Wang	Nano Lett.	6	
Liu	Nat. Photonics	7	
Xiao	Adv. Mater.	8	
Zhou	Science	9	
Yang	Science	10	
Saliba	EES	11	
Yang	Science	12	



Figure S2 | Photo of experimental setup. 1: X-ray area detector; 2: antisolvent nozzle; 3: gas
nozzle; 4: X-ray aperture; 5: table to mount substrate; 6: blade; 7: vacuum line to hold substrate
and blade; 8: ink feed line; 9: motorized linear stage to scan film in X-ray beam; 10: motorized
linear stage to move blade; 11: seal to contain inert atmosphere (lid not shown).



Figure S3 | *In situ* XRD during drying of blade coated film at room temperature (DMF). The red
and black dashed lines indicate the calculated peak positions for the intermediate and perovskite
phase, respectively. The calculated peak positions are based on jp7b08468_si_002.cif.¹³



Figure S4 | *In situ* XRD during drying of blade coated film at room temperature (NMP). The red
and black dashed lines indicate the calculated peak positions for the intermediate and perovskite
phase, respectively. The calculated peaks are based on

- 31 <u>http://www.crystallography.net/cod/1011333.html</u> with the _cell_length_c parameter modified to
- 32 10.65 Å.
- 33



Figure S5 | *In situ* XRD during drying of blade coated film at room temperature (DMSO). The
 red and black dashed lines indicate the calculated peak positions for the intermediate and
 perovskite phase, respectively. The calculated peaks are based on ja5b10599_si_006 INT-3.cif
 ¹⁴, which is equivalent to c5nr02866c2.cif¹⁵.



Figure S6 | *In situ* XRD during drying and heating of blade coated film (DMF, no CB). The red
and black dashed lines indicate the calculated peak positions for the intermediate and perovskite
phase, respectively. The solid black line shows the temperature (top abscissa).



Figure S7 | *In situ* XRD during drying and heating of blade coated film (DMF, CB added at 0
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The solid black line shows the temperature (top abscissa).



Figure S8 | *In situ* XRD during drying and heating of blade coated film (DMF, CB added at 2
min). The red and black dashed lines indicate the calculated peak positions for the intermediate

and perovskite phase, respectively. The green dashed line marks the addition of chlorobenzene.

55 The solid black line shows the temperature (top abscissa).

56

51



Figure S9 | *In situ* XRD during drying and heating of blade coated film (NMP, no CB). The red
and black dashed lines indicate the calculated peak positions for the intermediate and perovskite
phase, respectively. The solid black line shows the temperature (top abscissa).



Figure S10 | *In situ* XRD during drying and heating of blade coated film (NMP, CB added at 0
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The solid black line shows the temperature (top abscissa).



Figure S11 | *In situ* XRD during drying and heating of blade coated film (NMP, CB added at 2
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The green dashed line marks the addition of chlorobenzene.
The solid black line shows the temperature (top abscissa).



Figure S12 | *In situ* XRD during drying and heating of blade coated film (NMP, CB added at 8
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The green dashed line marks the addition of chlorobenzene.
The solid black line shows the temperature (top abscissa).



Figure S13 | *In situ* XRD during drying and heating of blade coated film (NMP, CB added at 20
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The green dashed line marks the addition of chlorobenzene.
The solid black line shows the temperature (top abscissa).



Figure S14 | *In situ* XRD during drying and heating of blade coated film (DMSO, no CB). The
red and black dashed lines indicate the calculated peak positions for the intermediate and
perovskite phase, respectively. The solid black line shows the temperature (top abscissa).



Figure S15 | *In situ* XRD during drying and heating of blade coated film (DMSO, CB added at 0
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The solid black line shows the temperature (top abscissa).



Figure S16 | *In situ* XRD during drying and heating of blade coated film (DMSO, CB added at 2
min). The red and black dashed lines indicate the calculated peak positions for the intermediate
and perovskite phase, respectively. The green dashed line marks the addition of chlorobenzene.
The solid black line shows the temperature (top abscissa).





112 10 min). The red and black dashed lines indicate the calculated peak positions for the

intermediate and perovskite phase, respectively. The green dashed line marks the addition of

114 chlorobenzene. The solid black line shows the temperature (top abscissa).





123 chlorobenzene addition is indicated in the top right of each image. The solvent system used and

the image scale is shown on the right of each row.











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Figure S20 | XRD data for finished films after thermal annealing. **a**) Two-dimensional GIWAXD images represented in $q_{xy} - q_z$ space, **b**) Integrated one-dimensional diffraction curves (vertically shifted). The peak labeled with an asterisk is due to diffraction from the polyimide X-ray window.^{13,16,17}

142 Film Thickness Measurements using Interferometry

143 The film thickness was measured during blade coating and drying using a Thetametrisis FR-

144 pOrtable interferometer. The refractive indices for DMF, DMSO and NMP for certain

145 wavelengths were obtained from the literature¹⁸ and then fit to the Cauchy equation¹⁹:

146
$$n(\lambda) = A + \frac{B}{\lambda^2} + \frac{C}{\lambda^4}$$

147 with the refractive index *n*, the wavelength λ and the Cauchy fit parameters *A*, *B*, *C*. The resulting

148 fits are shown in fig. S8.



149

Fig. S21 | Cauchy fits for the refractive indices for NMP, DMF and DMSO (pure solvents). Next, the refractive indices for the mixed solvents n_{mix} were computed using the Lorentz-

Lorenz mixing rule²⁰ (fig. S9):

153
$$n_{mix}(a) = \sqrt{\frac{2a+1}{1-a}}$$

154
$$a = \phi_1 t(n_1) + \phi_2 t(n_2)$$

155
$$t(n) = \frac{n^2 - 1}{n^2 + 2}$$

156 with the volume fraction ϕ_i for solvent *i*.

157 The refractive indices of the solution were assumed to be consistent with those of the mixed 158 solvents, i.e. the contributions of the solutes (and their varying concentration over time) were 159 neglected. For that reason, the reported thicknesses should be interpreted as relative values.





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